Substitute for form 1449/PTO				Complete if Known		
		9/P1O		Application No.:	10/549,863	
INFORMATION DISCLOSURE ATEMENT BY APPLICANT (Use as many sheets as necessary)				Filing Date:	December 8, 2006	
				First Named Inventor:	Nigel P. Smith	
				Art Unit:	2823	
				Examiner Name:	William D. Coleman	
Sheet	1	of	1	Attorney Docket No.:	NAN154 US 8026	

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Examiner	Date	
Signature:	Considered:	

^{*} Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication with applicant.